



ELECTRONIC COPY

LG778684449
Report verification at igi.org



March 6, 2026
IGI Report Number **LG778684449**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **SQUARE CUSHION MODIFIED BRILLIANT**
Measurements **7.46 X 7.37 X 4.87 MM**
GRADING RESULTS
Carat Weight **2.02 CARATS**
Color Grade **E**
Clarity Grade **VVS 2**

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GRADING RESULTS

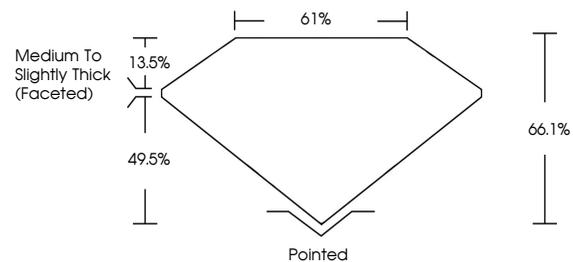
Carat Weight **2.02 CARATS**
Color Grade **E**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG778684449**

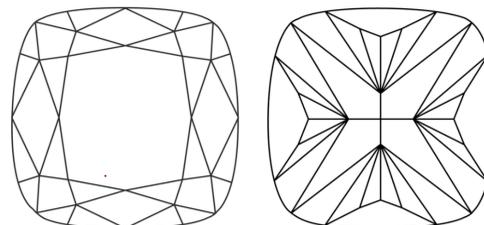
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

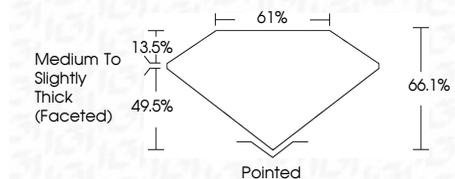
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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SQUARE CUSHION MODIFIED BRILLIANT
2.02 CARATS
E
Carat Weight
Color Grade
Clarity Grade **VVS 2**
Depth **66.1%**
Table **61%**
Girdle
Medium to Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG778684449
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